
Microfluidics — Vocabulary

Microfluidique — Vocabulaire

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Published in Switzerland

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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see www.iso.org/directives).

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This document was prepared by Technical Committee ISO/TC 48, *Laboratory equipment*, in collaboration with the European Committee for Standardization (CEN) Technical Committee CEN/TC 332, *Laboratory equipment*, in accordance with the Agreement on technical cooperation between ISO and CEN (Vienna Agreement).

This second edition cancels and replaces the first edition (ISO 10991:2009), which has been technically revised.

The main changes are as follows:

- title has been changed;
- several terms have been added to reflect the increased uptake of microfluidic technology.

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at www.iso.org/members.html.

Microfluidics — Vocabulary

1 Scope

This document provides terms and definitions for micro process engineering and microfluidics applied in medical and veterinary diagnostics, chemistry, agriculture, pharmacy, biotechnology and the agrifood industry, as well as other application areas.

2 Normative references

There are no normative references in this document.

3 Terms and definitions

ISO and IEC maintain terminology databases for use in standardization at the following addresses:

- ISO Online browsing platform: available at <https://www.iso.org/obp>
- IEC Electropedia: available at <https://www.electropedia.org/>

3.1 General terms, relevant to microfluidics

3.1.1

biocompatibility

special quality of some materials allowing them to come into contact with biological materials without changing the materials' bioactivity

3.1.2

biomarker

biological molecule found in blood, other body fluids or tissues that is used to identify a disease or monitor the progression of a disease

3.1.3

classification

method of sorting into categories

[SOURCE: ISO 5492:2008, 4.5]

3.1.4

end-user

person or persons who will ultimately be using the *system* (3.1.15) for its intended purpose

[SOURCE: ISO/IEC 19770-5:2015, 3.13, modified — Note 1 to entry has been removed.]

3.1.5

hydrophilic

characterised by affinity to water established by hydrogen bonding

3.1.6

hydrophobic

characterised by being repelled from a mass of water

3.1.7
interested party
stakeholder

person or organization that can affect, be affected by, or perceive itself to be affected by a decision or activity

[SOURCE: ISO 9000:2015, 3.2.3, modified — EXAMPLE and Note 1 to entry removed.]

3.1.8
interoperability

property permitting diverse *systems* (3.1.15) or *components* (3.4.7) to work together for a specified purpose

[SOURCE: IEC 80001-1:2010, 2.11]

3.1.9
macroscale

scale of dimensions of 0,1 mm or greater

[SOURCE: SEMI MS003:2015, 6.59]

3.1.10
microfluidics

manipulation of fluids that are confined in a small volume with at least one dimension smaller than 1 mm

3.1.11
microscale

scale of dimensions between $0,1 \times 10^{-3}$ m to $0,1 \times 10^{-6}$ m

3.1.12
miniaturization

action of making things on a smaller scale

3.1.13

plug and play

ability to work perfectly when first used or connected, without reconfiguration or adjustment by the user and thereby enabling automatic configuration

3.1.14
wettability

ability of a liquid to spread on a specific solid surface

[SOURCE: ISO 472:2013, 2.1607, modified — wording “(such as an adhesive)” has been deleted and Note 1 to entry has been removed.]

3.1.15
system

group of interacting microfluidic, optical, mechanical or electrical *components* (3.4.7)

3.1.16
actuating resolution

lowest variation of a physical parameter that can be operated by a *system* (3.1.15)

3.1.17
capacity

flow rate through a pump at its designed conditions

3.1.18**centrifugal microfluidics**

subcategory of *microfluidics* (3.1.10) utilizing rotation

Note 1 to entry: The fluid flow is mainly controlled by centrifugal-, Euler- and Coriolis- forces.

3.1.19**closed system**

system (3.1.15) that uses preloaded manufacturer-specific reagents only

3.1.20**digital microfluidics**

subcategory of *microfluidics* (3.1.10) where discrete quantities of liquid are manipulated individually over a surface

3.1.21**droplet microfluidics**

subcategory of *microfluidics* (3.1.10) manipulating discrete quantities of liquid in a continuous flow

3.1.22**lab-on-a-chip****LoC**

highly integrated, microfluidic *system* (3.1.15) providing analytical or diagnostic functions

3.1.23**open system**

system (3.1.15) that requires an external supply of reagents

Note 1 to entry: Such an open system requires microfluidic connection(s).

3.1.24**resolution**

smallest change in a quantity being measured that causes a perceptible change in the corresponding measurement indication

3.1.25**sensing resolution**

lowest variation of a physical parameter that can be detected by a sensor

3.2 Terms related to microfluidic flow**3.2.1****actual flow rate**

volumetric flow rate of a gas changed to standardized conditions of temperature and pressure

3.2.2**capillarity****capillary action**

flowing of liquid through a device without external actuators but only by the surface tension and the adhesive force between liquid and the wetted material

3.2.3**compliance of a fluidic system**

increase of a fluidic *system's* (3.1.15) internal volume under the effect of pressure

Note 1 to entry: The compliance of a fluidic system is expressed in volume units per pressure units.

**3.2.4
dead volume**

portion of the internal volume of a *system* (3.1.15) that is not part of a continuous flow-path

Note 1 to entry: In this context dead signifies unmoving, stagnant, or un-swept. The dead-volume is expressed in volume units.

**3.2.5
fall time**

time required for a flow to change from a specified high value to a specified low value

Note 1 to entry: Typically, these values are 10% and 90% of the step height. The fall time is expressed in time units.

**3.2.6
final steady-state value**

average value of the *actual flow rate* (3.2.1), after the effects of the input transient have faded to a value equal to or below the intrinsic drift and noise

Note 1 to entry: The final steady-state flow rate value is expressed in volume units or mass units over time units.

[SOURCE: SEMI E17-0600:2000, modified — “flow rate” and “mass units” have been added in Note 1 to entry.]

**3.2.7
hold-up volume**

volume of fluid required to fill a device before a flow is observed at the point of interest or the outlet

Note 1 to entry: The hold-up volume is expressed in volume units such as mm³ or microlitre.

[SOURCE: SEMI MS003:2015, 6.51, modified — “units” has been added in the Note 1 to entry.]

**3.2.8
hydrodynamic resistance**

ratio of pressure drop over flow rate for a certain *component* (3.4.7) or *system* (3.1.15)

Note 1 to entry: The hydrodynamic resistance is expressed as pressure units per flow rate units.

**3.2.9
hydrostatic pressure**

pressure that is exerted by a fluid contained within a *system* (3.1.15) due to the force of gravity

Note 1 to entry: The hydrostatic pressure is expressed in pressure units.

**3.2.10
internal volume**

maximal total available volume comprised within a fluidic *component* (3.4.7), device or *system* (3.1.15) under normal atmospheric pressure

Note 1 to entry: The internal volume is expressed in volume units such as mm³ or microlitre.

**3.2.11
mass flow rate**

mass of fluid which passes per unit of time

Note 1 to entry: The mass flow rate is expressed in mass units per time units.

**3.2.12
micropump**

miniaturized liquid or gas pumping equipment with a *capacity* (3.1.17) of lower than 1 ml/min

3.2.13**minimal actuating pressure**

input pressure required to start moving a fluid through the fluidic *component* ([3.4.7](#))

Note 1 to entry: Minimal actuating pressure is expressed in pressure units.

3.2.14**pressure drop**

difference of pressure between two positions in the flow path

Note 1 to entry: The pressure drop is expressed in pressure units.

3.2.15**reaction time**

time interval between the moment of the set point step change and the moment at which the flow reaches x % (below 20 %) of its intended value of rise or fall

Note 1 to entry: Typically, $x = 10$. The reaction time is expressed in time units.

Note 2 to entry: See also [Figure 1](#).

3.2.16**relative flow stability****coefficient of variation**

standard deviation of the flow rate divided by the average flow rate

Note 1 to entry: The relative flow stability is expressed as a percentage.

3.2.17**response time**

time interval between the moment of the set point step change and the moment at which the flow reaches y % (above 80 %) of its intended value of rise or fall

Note 1 to entry: Typically, $y = 90$. The response time is expressed in time units.

Note 2 to entry: See also [Figure 1](#).

3.2.18**rise time**

time required for a flow to change from a specified low value to a specified high value

Note 1 to entry: Typically, these values are 10 % and 90 % of the step height. The rise time is expressed in time units.

Note 2 to entry: See also [Figure 1](#).

3.2.19**set point**

target flow rate value

Note 1 to entry: See also [Figure 1](#).

3.2.20**settling time**

time elapsed from the application of an ideal step input to the time at which the output has been entered and remained within a *specified (error) band* ([3.2.21](#))

Note 1 to entry: The settling time is expressed in time units.

Note 2 to entry: See also [Figure 1](#).

**3.2.21
specified error band
specified band**

the difference between the specified most negative and specified most positive deviation from the set point

Note 1 to entry: See also [Figure 1](#).

**3.2.22
step response time**

time between the *set point* ([3.2.19](#)) step change and the instant when the actual flow first enters the specified band

[SOURCE: SEMI E17-0600:2000, modified — “the instant” has been added.]

**3.2.23
swept volume**

portion of a volume that is part of the flow path

Note 1 to entry: The swept volume is expressed in volume units.

Note 2 to entry: The swept volume is the internal volume minus the dead volume.

**3.2.24
transient overshoot**

maximum change in actual flow minus the steady-state change in actual flow expressed as a percentage of the *set point* ([3.2.19](#)) step change

Note 1 to entry: See also [Figure 1](#).

[SOURCE: SEMI E17-0600:2000]

**3.2.25
transient undershoot**

maximum amount that the actual flow passes beyond the *final steady-state value* ([3.2.6](#)), in the opposite direction of overshoot, expressed as a percentage of the *set point* ([3.2.19](#)) step change

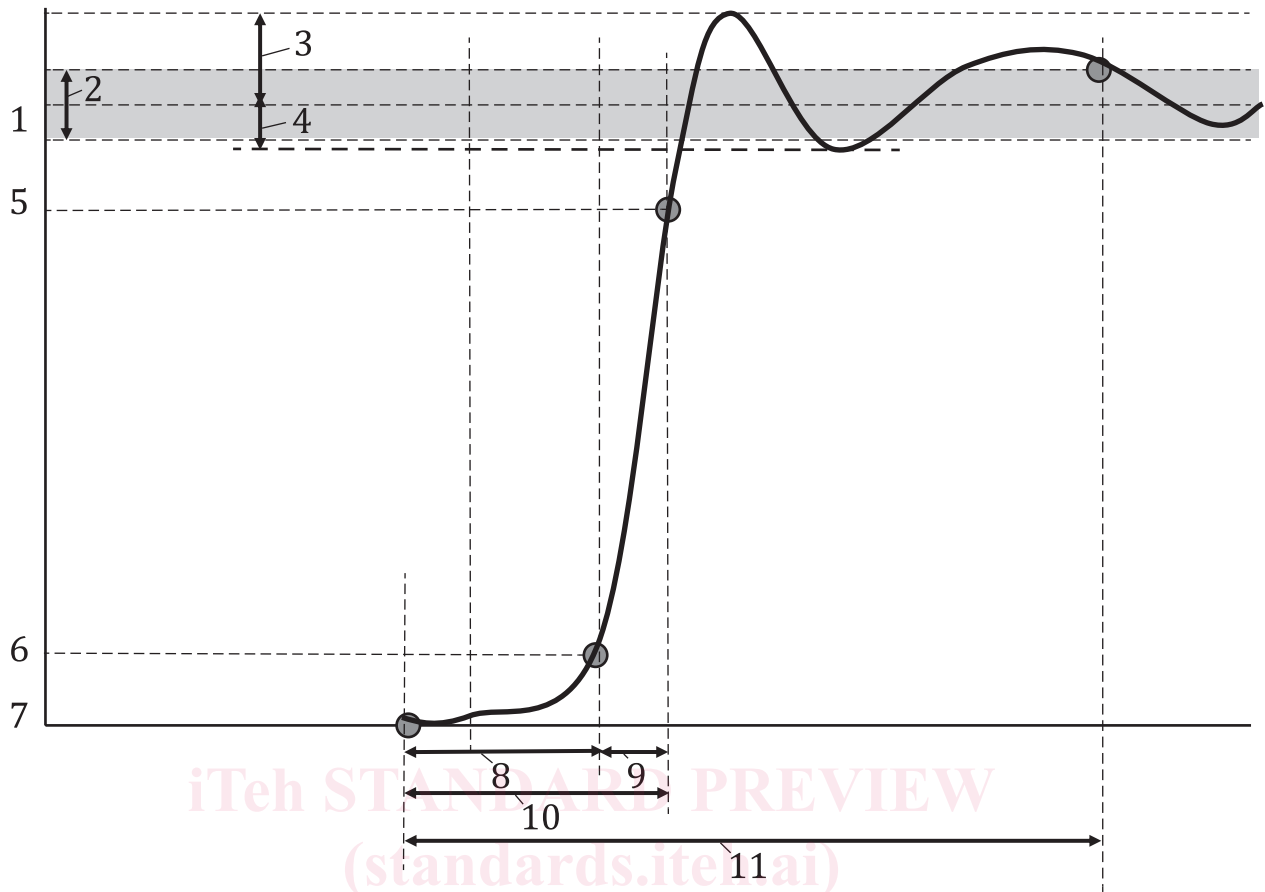
Note 1 to entry: See also [Figure 1](#).

[SOURCE: SEMI E17-0600:2000, modified — “beyond” added.]

**3.2.26
volumetric flow rate**

volume of fluid which passes the *system* ([3.1.15](#)) per unit of time

Note 1 to entry: The volumetric flow rate is expressed in volume units per time units.

**Key**

1	set point (100 % rise)	7	initial set point (0 %)
2	specified (error) band	8	reaction time
3	transient overshoot	9	rise time
4	transient undershoot	10	response time
5	y % rise	11	setting time
6	x % rise		

Figure 1 — Schematic showing flow control terms related to a step change in flow

3.3 Terms related to microfluidic interfacing

3.3.1

first-level connection

direct connection

connection enabling liquid transfer between two parts through direct contact (without *tubes* (3.4.24))

3.3.2

second-level connection

indirect connection

connection enabling liquid transfer between two parts using *tubes* (3.4.24), syringes, O-rings, *gaskets* (3.3.13) and other type of connections (chip to tube)

3.3.3

adhesive connection

connection by a length of tubing bonded to a port on the microfluidic device with epoxy or another suitable adhesive